## **REMARKS**

A new title has been presented by the Applicant, namely "METHOD OF MANUFACTURING DISTRIBUTED ANALOG PHASE SHIFTER USING ETCHED FERROELECTRIC THIN FILM" which Applicant clearly and distinctly regards as the title of the invention, and as further pointed out by the Examiner in the Election/Restriction Requirement mailed on 08/24/2005 in which the election to Group II, claims 6-10, as acknowledged by the Examiner in Part of Paper No./Mail Date 20051201, was noted as being "drawn to a method for etching a ferroelectric phase shifter, classified in class 216, subclass 13." Therefore, entry pursuant to Rule 312 is requested.

Respectfully submitted,

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Dated: (0/3/106

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## **CERTIFICATE OF MAILING:**

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October 3/1, 2006